

## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re A	Application of:	)	
NORI	UHIRO ITO	:	Examiner: B. Talbot
NOD	3111KO 110	:	Group Art Unit: 1762
Appli	cation No.: 09/505,627	)	<b>F</b>
Filed:	February 16, 2000	)	
For:	MANUFACTURING METHOD OI ELECTRON BEAM APPARATUS AND SPACER, AND ELECTRON		
	REAM APPARATUS	•	March 18, 2005

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Since the U.S. Patent and Trademark Office waived the requirement under 37 C.F.R. § 1.98 (a)(2)(i) for submitting a copy of each cited U.S. patent and each U.S. patent application publication for all U.S. national patent applications and for all international applications that have entered the national stage under 35 U.S.C. § 371, no copies of such documents are enclosed. Copies of the other listed document are enclosed.

03/22/2005 FMETEKI1 00000054 09505627

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

March 18, 2005 (Date of Deposit)

Jason M. Okun
(Name of Attorney for Applicant)

Signature

March 18, 2005
Date of Signature

This Information Disclosure Statement is to make of record documents cited

in an Official letter in the corresponding Japanese application.

The concise explanation of relevance of the non-English documents may be

found, inter alia, in the English language abstracts attached thereto. In addition, the

concise explanation of relevance for JP 2000-164129 may be found in U.S. Patent No.

6,517,399 B2, which is in the same patent family. The concise explanation of relevance for

JP 8-508846 may be found in WO 94/18694, which is the same patent family. Lastly, the

concise explanation of relevance for JP11-073897 may be found in U.S. Patent Nos.

6,153,973 and 6,353,280 B1, which are all in the same patent family.

**CONCLUSION** 

It is respectfully requested that the above information be considered by the

Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such

information has been considered.

We also enclose a check for the required fee of \$180.00 to cover the

Information Disclosure Statement under 37 C.F.R. § 1.97(c)(2).

Applicant's undersigned attorney may be reached in our New York office by

telephone at (212) 218-2100. All correspondence should continue to be directed to our

address given below.

Respectfully submitted,

Attorney for Applicant

Registration No. 48,512

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- 2 -

FORM PTO 1449 (modified)				ATTY DOCKET NO. 03500.014241		APPLICATION NO. 09/505,627			
U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)  MAR 2 1 2005    O				APPLICANT Nobuhiro Ito					
				FILING DATE February 16, 2000			GROUP 1762		
	-	E S		USP	PATENT DOCUMENTS			<u></u>	
*EXAMINER INITIAL		U.  TRABBOGAN NT DATE		NAME		CLAS	S SUBCLASS	FILING DATE	
		6,517,399 B2	02/11/0	03	Ito et al.	445	24		
		6,153,973	11/28/	00	Shibata et al.	313	495		
		6,353,280 B1	03/05/	02	Shibata et al.	313	292		
			FO	REIGI	N PATENT DOCUMENTS				
		DOCUMENT NUMBER	DATE		COUNTRY	CLAS	S SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT	
	EP	0 405 262 A1	01/02/9	91	Europe				
	wo	94/18694	08/18/9	94	International				
	JP	2000-164129	06/16/	00	Japan			Abstract	
	JP	11-73897	03/16/	99	Japan			Abstract	
	JP	8-508846	09/17/		Japan			Abstract	
		OTHER D	OCUMENT(S	) (Inclu	uding Author, Title, Date, Pertinent Pages, Etc.)				
			<u> </u>			-			
FXAMINER					DATE CONSIDERED				

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet	1	of	1